

OTPE JCIBI  
APR 01 2003  
TRADEMARK REG. U.S. PAT. & TM. OFF. PHOENIX, AZ

Date of Deposit

Name of Applicant, Assignee or Registered Representative

**Signature**

RECEIVED  
APR 08 2003  
GROUP 1700

**In re Application of:**

# Thinghao F. Wang

**Serial No. 10/071,809**

**Filing Date: February 7, 2002**

For METHOD FOR SELECTIVELY  
ETCHING SILICON AND/OR  
METAL SILICIDE

**Examiner: Deo, Duy Vu**

Group Art Unit No.: 1765

**Dear Sir:**

Please charge the \$930.00 filing fee to American Express Account No. 3785-716974-01002. A Credit Card Payment Form is attached. A duplicate copy of this Petition is attached.

Respectfully submitted,

SONNENSCHN NATH & ROSENTHAL  
P. O. BOX 061080  
WACKER DRIVE STATION, SEARS TOWER  
CHICAGO, IL 60606  
(312) 876-8000